

Search Notes				Application/Control No.	Applicant(s)/Patent under Reexamination	
				10/673,639	MASSEY ET AL.	
				Examiner	Art Unit	
				José V. Chen	3637	

SEARCHED			
Class	Subclass	Date	Examiner
52	204.1	3/25/06	JCC
	717.01		
	717.02		
49	467		
	469		
	471		
	504		
	505		
	507		
	510A700	4/12/07 JU	
52	204.51		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Search for Sack IN 52	3/27/06	JCC
Search for Spitzer IN 49		
✓10A700	4/12/07 JU	
Text Search first. Discussed w/Sasson		

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
52	204.1	4/12/07 JU	